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Electron scattering in scanning probe microscopy experiments

Linda A. Zotti ^a, Werner A. Hofer ^{a,*}, Franz J. Giessibl ^b

^a Surface Science Research Centre, Department of Chemistry, University of Liverpool, Liverpool L69 3BX, United Kingdom ^b Universität Augsburg, Institute of Physics, EKM, EP 6, 86135 Augsburg, Germany

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Abstract

It has been shown that electron transitions, as measured in a scanning tunnelling microscope, are related to chemical interactions in a tunnelling barrier. Here, we show that the shape and apparent height of subatomic features in both, measurements of the attractive forces in an atomic force microscope, and measurements of the tunneling current between the Si(111) surface and an oscillating cantilever, depend directly on the available electron states of the silicon surface and the silicon tip. Simulations and experiments confirm that forces and currents show similar subatomic variations for tip-sample distances approaching the bulk bonding length. © 2005 Elsevier B.V. All rights reserved.

The intense research into improving the local and energy resolution in scanning probe microscopes (SPM) over the last two decades have made the assignment of atomic features to the position of surface ions attainable in many cases by comparing experimental data to high level numerical simulations. The very high resolution of individual features in the experiments, today below the limit of 1 Å, makes it possible to carry out detailed studies of the electronic structure and their local extension, which a decade ago have been thought impossible. The greater simplicity of physical processes in an scanning tunnelling microscope (STM), where long-range forces and the dynamics of an oscillating cantilever do not enter the picture, seemed to allow accurate comparisons between STM experiments and theory quite early. However, also in this case interactions and atomic displacements in a tunneling junction may decisively alter the image [1]. The advent of the atomic force microscope (AFM) extended the range of experiments substantially, since AFM experiments do not rely on the transition of electrons through the tunnelling barrier, and can therefore in principle be performed on all materials [2]. Today, AFM is able to reveal finer details than STM [3–6]. Theoretically, the advance in quantitative

* Corresponding author. E-mail address: whofer@liverpool.ac.uk (W.A. Hofer). models of AFM and their predictive power made it possible to analyze the differences between simple theoretical models and the obtained experimental results: by gradually obtaining a more realistic view of the experimental situation, the role of different interactions and their effects on SPM images was determined [7–9]. The simple initial models could thus be corrected, e.g., for the effects of atomic relaxations, of ionic charge, or dissipation processes during AFM scans [10].

In this Letter, we show that the subatomic features, observed by AFM and STM measurements with oscillating cantilevers on Si(111) (7 \times 7), which have been the subject of intense debate [3,4,11], are due to the scattering of electrons from a very narrow energy range at the surface into double dangling bonds of the silicon tip.

The Si(111) surface was simulated by a four layer silicon film, the bottom layer was passivated with hydrogen. The ionic positions were determined by fully relaxing the surface layers until the Hellman–Feynman forces on individual ions were less than 0.01 eV/Å. The electronic groundstate was then calculated using ultrasoft pseudopotentials for the ionic cores with the VIENNA AB INITIO SIMU-LATION Program [12,13]. Due to the size of the system, which comprises 249 ions in the unit cell, the calculation was limited to only one k-point, the $\overline{\Gamma}$ point. The energy cutoff for the plane-wave expansion was set to 250 eV.

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The atomic arrangement in the final iteration and the (7×7) unit cell is shown in Fig. 1a. After the electronic groundstate structure had been calculated the Kohn-Sham states in the energy interval $E_{\rm F} \pm 3$ eV were extracted. Testing the resolution of the ensuing images based on the electronic surface structure alone we found that the detailed features are quite sensitive to the cutoff in the two dimensional Fourier expansion of the single electron states. To obtain high resolution images it was necessary to expand every state with close to 500 reciprocal lattice vectors. The density of electron charge within the interval $[E_{\rm e} - 2 \, {\rm eV}, E_{\rm F}]$ in a horizontal plane above the surface is shown in Fig. 1b. The contributions to the charge density at -2 eV are shown in (c). It can be seen that the differential contributions show a double feature at the position of the adatoms, which is missing in the density contour over the whole bias interval. This indicates that the double features are due to electron states with an energy close to -2 eV relative to the Fermi level. An integration over the whole bias range sums up a large number of individual states, the double feature, which we attribute to single electron states, is then no longer observable.

The tip model in our simulations is a (2×2) Si(001) surface with a single silicon atom, as suggested by an analysis of high resolution AFM experiments [3]. The tip was simulated by an eight layer film with a hydrogen passivated bottom layer. Since the tip system is somewhat smaller we increased the number of k-points of the tip system to nine k-points near the center of the tip Brillouin zone, including the $\overline{\Gamma}$ point. The single silicon atom at the tip apex leads to two dangling bonds protruding from the tip apex. We simulated two STM tips, obtained by rotating the atoms of the original cell by 90° while keeping the lattice vectors constant. To obtain the current maps and the locally resolved dI/dV spectra of the surface we employed a newly developed method, described in [15,16]. The

scattering method, calculated to first order in the interface Green's function accounts for the bias dependency with the help of an additional term, which depends on the bias potential eV and the exponential decay of surface and tip states $\kappa_{i(k)}$, according to [16]:

$$I(V) = \frac{4\pi e}{\hbar} \sum_{ik} \left[f\left(\mu_{\rm S}, E_k - \frac{eV}{2}\right) - f\left(\mu_{\rm T}, E_i + \frac{eV}{2}\right) \right] \\ \times \left| \left(\frac{\hbar^2}{2m} - \frac{eV}{\kappa_k^2 - \kappa_i^2}\right) M_{ik} \right|^2 \delta(E_i - E_k + eV).$$
(1)

Here, f is the Fermi distribution function, $\mu_{S(T)}$ is the chemical potential of the surface (tip), $E_{i(k)}$ the eigenvalue of surface (tip) states, and M_{ik} the Bardeen matrix element. The difference to the standard Bardeen method, the second term in the quadratic expression, arises from the shift of eigenstates due to the applied bias voltage. It accounts for the bias dependency in the tunnelling junction. High resolution spectra for the bias range ± 2 V were directly calculated by a map of differential changes as the bias voltage is ramped up. The method, described in [15] is more efficient than numerically differentiating the I(V) map, it also allows to separate contributions due to the bandstructure of the STM tip. It should be noted that the simulation of tunneling spectra and currents does not include relaxations of surface or tip atoms, which were frozen at their groundstate positions.

The experiments were conducted with a combined scanning tunneling/atomic force microscope at room temperature in an ultrahigh vacuum at $p \approx 10^{-10}$ mbar. The Si(111) sample (p-doped Si(111) wafer, resistivity 9.0 Ω cm, MacTecK, Jülich, Germany) was prepared with a standard technique involving heating to 1280 °C for about 30 s. In order to facilitate comparison between theory and experiment, simultaneous force and current measurements are performed in the constant-height mode,



Fig. 1. (a) Position of atoms in the surface layer (blue) and adatoms (red) in the final iteration. (b) Constant density contour of all electron states in the interval $[E_F - 2 \text{ eV}, E_F]$ at a median distance of 3.5 Å. Atoms are seen as single protrusions. (c) Contributions of electron states at an energy value of $E_F - 2 \text{ eV}$. Double features of states at the silicon surface in this case are clearly visible. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

where the tip scans in a plane parallel to the surface. Measuring the tip-sample forces directly is impractical because of experimental noise and strong background forces [23]. Therefore, we resort to frequency modulation force microscopy [24] where the frequency shift of an oscillating cantilever is measured. We used a qPlus cantilever [21] in this study with a spring constant of k = 1800 N/m, an eigenfrequency of $f_0 = 11\,886\,\text{Hz}$ and an oscillation amplitude of A = 9.4 Å. While the tip of the force sensor consisted of an etched tungsten tip, we found that the active tip cluster consists of Si picked up from the surface during the tip preparation process that involves controlled collisions with the Si sample accompanied by voltage pulses. After this process, we frequently find craters on the Si surface where the missing sample material is not found anywhere close on the surface. Scanning electron microscopy images of these 'tungsten' tips reveal sharp-edged clusters with a size similar to the observed craters on the surface ($\approx 100 \text{ nm}$). Because the tip oscillates, the experimental observable is an average tunneling current I_{av} and a frequency shift Δf . $I_{\rm av}$ is given by the peak current divided by $\sqrt{4\pi\kappa A}$, where κ is the decay rate of the tunneling current (Eq. 43 in [23]). With $\kappa \approx 1 \text{ Å}^{-1}$ and A as given above, we find a peak current of 10.8 times the average values given in the captions of Fig. 3. The frequency shift is given by $\Delta f / f_0 k A^{3/2} \approx 0.4 F_{ts} \sqrt{\lambda}$ where the range λ of the tip-sample force $F_{\rm ts}$ is given by $\lambda = 1/(2\kappa)$ [10]. The typical frequency

shift in this experiment is -5 Hz, thus the estimated tipsample force at closest distance is -5 nN. The results of topographic simulations at a bias voltage of -2 V are shown in Fig. 2.

Current simulations were performed with the tip unit cell of the extended Si(001) tip system aligned to the horizontal and vertical axes of the surface unit cell. For high current values of 0.5 nA the topographic images show a double feature: two protrusions with a depression in vertical alignment for all adatoms of the surface, with the exception of one corner atom (Fig. 2a). The stability of the numerical results was analyzed by performing the simulations with 100, 200, or 488 lattice vectors. The results given are obtained with the expansion of highest resolution, but even in this case the double feature at one corner atom, which is clearly visible in high-resolution spectrum simulations (see further down), could not be resolved. In all other cases, however, the constant current contour reveals double features (Fig. 2a,b). The details of the features depend on the orientation of the tip, as a comparison between Fig. 2a,b reveals. The detail shows the shape of one protrusion, which is rotated if the tip rotates by 90°. It is interesting to note that detail (d) is actually not only rotated, but also reflected compared to detail (c). The additional mirror plane reflects the reflected vertical orientation of the STM tip. The shape of the protrusion (a horseshoe) deviates slightly from the shape of the protrusions in the density



Fig. 2. Constant current contour at -2 V, simulated for two different silicon tips in (001) orientation. (a,b) Constant current contours at a current value of 0.5 nA. The double features at the surface are clearly visible, the rotated tip cell leads to a rotation of features in the image (see details). (c,d) Constant density contour of the two tip unit cells at plus 2 eV. The double dangling bond is rotated by 90°. (e,f) Constant current contour at a current value of 20 pA. The double features at this distance are difficult to observe, and there is no substantial difference between the images obtained with different tips. (g,h) Linescans and apparent height at the center of the cell (see dashed white line). The current values are 0.5 nA (solid lines), and 20 pA (dashed line). (i,k) Constant force contours of 3.0 nN (i), and 0.3 nN (k). The images are very similar to the constant current contours.

contours at a bias voltage of -2V (double peaks, see Fig. 1). The reason for this deviation is most likely the tilting angle of the tip apex. However, the mismatch between theory and experiments (see Fig. 3), which leads to an artificial bridge between the two protrusion, is comparatively minor. Moreover, the simulated density contours and the tunneling spectra including the tip do not show the bridge between the two protrusions. Also the numerical values are in good agreement with experimental data. For comparison, we also show constant force contours of the surface for 3.0 and 0.3 nN (Fig. 2i,k), and one of the tip models. In this case, we used the fact that the interaction energy is proportional to the tunneling current at a given bias voltage [17], and calculated the interaction energy for a single point between the surface and a truncated tip apex of five silicon atoms. The covalent bonds of silicon in the tip cluster were passivated by hydrogen.

The simulations establish that the origin of the double feature is the convolution of surface states at the Si(111) surfaces and states at the mono-atomic Si(001) tip. By contrast, a simulated scan of the same surface with a tungsten tip does not show any double features even at very close distances. This is quite understandable, if one considers the spatial distribution of dangling bonds on the front atom of the silicon tip, which is much more focussed than that of the electron states at the apex of a tungsten tip. In addition, the local resolution is diminished by a large number of nearly equivalent tip states, which can be used as a drain for tunnelling electrons.

The occurrence of double features in the constant current contours is distance dependent. Figs. 2e,f show constant current contours of 20 pA. At this current, which is roughly in the range of most STM experiments, the double features at the positions of silicon adatoms have nearly vanished. The median distance at this current value, shown in the linescans (g) and (h), is still only about 4 Å, which is a range that is too close for conventional STM. It seems that even with a silicon tip apex in (001) orientation, the features are difficult to observe in conventional STM experiments. To sum up the argument, we may say that even though the double features pertain to the electronic structure of the silicon surface, they are only visible in dynamic STM [19] or dynamic AFM with a very peculiar choice for the tip. The reason, that dynamic STM/AFM can scan at distances of less than 3 Å, i.e. in a range, where the tip of conventional STM is broken, is the near absence of shear forces on the tip. An equivalent situation in STM experiments would be an approach and retraction cycle, and in this case it has been shown that the STM tip can approach to the point of contact without breaking [18,20].

In Fig. 3, we show simultaneously acquired images of the current averaged over one oscillation (Fig. 3a,c,e) and the frequency shift (Fig. 3b,d,f) in a combined AFM/ STM experiment. Up to a current of the current contours do not show a double feature in the images, even though the protrusions correspond to the protrusions in the frequency shift image. This indicates, as already pointed out in a previous paper [22], that current and interaction energy are indeed related. But considering that the double feature is present in the corner atoms at very close distances (Fig. 3f), it also reveals that the relation is not strictly linear at very low distances. The frequency shift in this case seems



Fig. 3. Simultaneous constant height images of tunneling current (left column) and frequency shift (right column). Sample bias -1.2 V, average tunneling current 0.1 nA (a), 0.5 nA (c) and 1.0 nA (e). The frequency shifts show a double feature at very close distances, the orientation of the double features is similar to the case simulated in Fig. 2d. The insets in (c)–(f) show 2× magnified views of one single adatom depicted by the square frames in the left bottom regions showing subatomic details.



Fig. 4. Conductance contours $dI/dV(x, y, z_0)$ for negative bias voltages of -2.0, -1.5, and -1.0 V (frames (a)–(c)); and for positive bias voltages +1.0, +1.5, and +2.0 V (frames, (d)–(f)) The double features in the conductance maps are only visible in the negative bias regime. In the positive range atoms are imaged only as single protrusions.

more sensitive to the details of the electronic structure than the current contour. In addition, the different orientation of the double features points to a rotation of the tip compared to the models used in the simulations.

In principle, the choice of the AFM tip model should also play a role in AFM simulations, if the resulting forces are simulated by moving a tip cluster above the silicon surface and calculating the ensuing interactions of the coupled system by density functional theory [4]. However, there is one qualification: interactions and forces depend on the transition of electrons from one side of the coupled system to the other [17]. If the energy difference between individual electron states of the decoupled subsystems is too large, the transmission probability will be reduced and the interaction energy will not be strongly affected. This means that the states of surface and tip, leading to the double features, must possess similar energies. The conjecture was checked by spectroscopy simulations with high local resolution, using the same silicon tip. Selected results of the obtained dI/dV maps are shown in Fig. 4. It can be seen that differential contributions show the double feature primarily in the bias range below -1.5 V (Fig. 4a,b). In the positive bias regime the adatoms are uniquely imaged as single protrusions (Fig. 4d,e,f). Comparing with experimental conditions in most STM images of the Si(111) surfaces it seems that this characteristic of images is one of the reasons for choosing primarily positive bias voltages corresponding to electrons tunnelling from filled tip states into empty surface states. Around the Fermi level the conductance and also the obtained current values are very low. However, we also note double features in the conductance contours in this range. This seems to explain to some extent the results of recent simulations. As AFM simulations are performed with zero bias, the transitions responsible for chemical interactions [10] involve primarily states in this range, which could lead to double features, even though their corrugation will be significantly smaller than in the negative bias regime. We may conclude from these results that the experimental data, obtained by AFM [3], which were taken at a sample bias of -1.5 V, utilized one range, where the double features appear. By contrast, the simulations, performed at zero bias, correspond to a different range. The whole picture only emerges, when the contributions to the tunnelling currents at varying bias are analyzed in detailed images with high local resolution.

The electrostatic potential between a conducting tip and an insulating sample is not well defined. However, experience shows that patch charges can lead to extremely large long-range forces that make it impossible to obtain true atomic resolution. Surface treatment of insulators for AFM imaging therefore often includes heating to reduce surface charges, growing thin films of insulators on metallic substrates, or evaporating metallic electrodes to the sidewalls of large insulators. Our study implies that potential differences of a few volts may change the appearance of atomic details and the short-range force versus distance spectra dramatically. Such a bias dependence has also been found by Arai and Tomitori in force spectra on conducting surfaces [25].

In summary we have shown that the sub-atomic features arise from a convolution of the electronic structure of the silicon surface and a silicon tip that is highly bias dependent. These features can be observed by *both* STM and AFM, if the tip-sample distance is sufficiently small. Stability considerations require the use of oscillating tips to reduce lateral forces when scanning very close to the sample. The occurrence of double peaks for single Si atom images is also limited to two narrow bias ranges: below about -1.5 V, and near the Fermi level in the positive bias regime.

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